



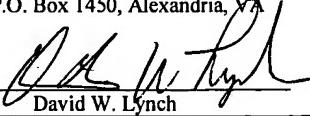
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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cyrille, et al
Serial No.: 10/633,765
Filed: 08/04/03
Title: Method for providing a liftoff process using a single layer resist and chemical mechanical polishing and sensor formed therewith

Examiner: Unassigned
Group Art Unit: 1763
Docket No.: HITG.025PA(0518)

CERTIFICATE UNDER 37 CFR 18: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on September 26, 2005.

By: 
David W. Lynch

REQUEST FOR CHANGE OF CORRESPONDENCE ADDRESS

Mail Stop Non-Fee Amendment
Commissioner for Patents
P. O. Box 1450
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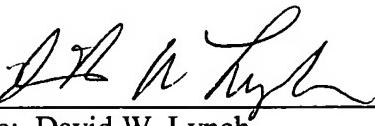
Dear Sir:

Please change the Correspondence Address for the above-identified application to:

Chambliss, Bahner & Stophel, P.C.
1000 Tallan Building
Two Union Square
Chattanooga, TN 37402
423-757-0264

Respectfully submitted,

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By: 
Name: David W. Lynch
Reg. No.: 36,204